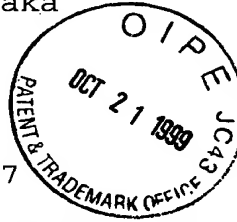


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hiroshi Tayanaka DOCKET NO.: P97,0027
SERIAL NO.: 08/818,239 BATCH NO.: B20
CLASS: 488
DATE FILED: March 14, 1997 EXAMINER: K. Christianson
GROUP ART UNIT: 2813
INVENTION: "METHOD FOR MAKING THIN FILM SEMICONDUCTOR (AS AMENDED)"



SUBMITTAL OF FORMAL DRAWINGS

Hon. Assistant Commissioner of Patents
Washington, D.C. 20231

OCT 26 1999

LETTER TO OFFICIAL DRAFTSMAN

Enclosed please find 27 sheets of formal drawings submitted in response to the Notice of Allowability PTOL-37 mailed on September 9, 1999 in connection with the above-identified case.

Applicant respectfully requests that the Examiner indicate that the drawings are acceptable so that the case may be passed to issue in view of the Notice of Allowability mailed on September 9, 1999.

Respectfully submitted,

(Reg. No. 35,902)

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Attorneys for Applicant

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231 on October 18, 1999.

Michael R. Hull